

<p align="center">NATIONAL PHASE UTILITY APPLICATION</p> <p align="center">Transmittal to the (DO/EO/US) Under 35 USC 371</p>	<p>Attorney Docket No.: SHIGA7.049APC First Named Inventor: Yasushi Washio Int'l Application No.: PCT/JP2004/017133 Int'l Filing Date: November 18, 2004 Priority Date Claimed: December 1, 2003 and September 13, 2004 Title: THICK FILM PHOTORESIST COMPOSITION AND METHOD OF FORMING RESIST PATTERN Express Mail Label No.: EV 465565784 US</p>
<p>Direct all correspondence to Customer No.: 20995</p> <p align="right">Date: May 4, 2006 Page 1 of 2</p>	

Mail Stop PCT

United States Patent and Trademark Office
P.O. Box 1450
Alexandria VA 22313-1450

The following enclosures are transmitted herewith to be filed in the patent application of:

Inventors:

1. Yasushi Washio
2. Koji Saito

APPLICATION ELEMENTS:

- (X) This is a FIRST submission of items concerning a filing under 35 U.S.C. § 371.
- (X) A copy of the International Application as published (35 U.S.C. § 371(c)(2)) is attached hereto.
- (X) A copy of the International Search Report for the International Application is attached hereto.
- (X) A copy of Form PCT/IB/304 for the International Application is attached hereto.
- (X) An English translation of the International Application as filed is not required.
- (X) Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. § 371(c)(3)) have not been and will not be made.
- (X) An Oath or Declaration signed by the inventors (35 U.S.C. § 371(c)(4)).

OTHER APPLICATION PARTS:

- (X) Preliminary Amendment in 5 pages.
- (X) Recordation form cover sheet and Assignment in 3 total pages (cover sheet & assignment).
- (X) Power of Attorney form and copy of assignment in 4 pages.
- (X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:
 - (X) Listing 3 references.
 - (X) Enclosing 1 reference.
- (X) Return prepaid postcard.

**NATIONAL PHASE
UTILITY APPLICATION**
Transmittal to the (DO/EO/US)
Under 35 USC 371

Attorney Docket No.: 20995-1
First Named Inventor: Yasushi Washio
Int'l Application No.: PCT/JP2004/017534
Int'l Filing Date: November 18, 2004
Priority Date Claimed: December 1, 2003 and September 13, 2004
Title: THICK FILM PHOTORESIST COMPOSITION AND
METHOD OF FORMING RESIST PATTERN
Express Mail Label No.: EV 465565784 US

AP2004-17534 PCT/PTO 04 MAY 2006

Direct all correspondence to Customer No.: 20995

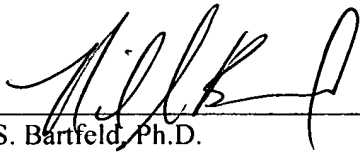
Date: May 4, 2006
Page 2 of 2

FILING FEES:

FEE CALCULATION				
FEE TYPE & DETERMINATION		LARGE FEE	CALCULATION	TOTAL
Basic Filing Fee under 1.492(a)		1631 (\$300)		\$300
Search Fee under 1.492(b) (enter one in TOTAL column)				
(1)	USPTO was ISA/IPEA & claims satisfy Art. 33 (1)-(4)	1640 (\$0)		\$400
(2)	USPTO was the ISA (noncompliant claims)	1641 (\$100)		
(3)	Foreign Search Report Enclosed	1642 (\$400)		
(4)	No Search Report Enclosed	1632 (\$500)		
Examination Fee under 1.492(c) (enter one in TOTAL column)				
(1)	USPTO was ISA/IPEA & claims satisfy Art. 33 (1)-(4)	1643 (\$0)		\$200
(2)	Non US IPEA or Noncompliant Claims	1633 (\$200)		
Excess Claims	9 - 20 = 0	1615 (\$50)	0 x 50 =	\$0
Excess Ind. Claims	1 - 3 = 0	1614 (\$200)	0 x 200 =	\$0
Multiple Dep. Claim		1616 (\$360)		\$360
Assignment		8021 (\$40)	1 x 40 =	\$40
			TOTAL FEE DUE	\$1,300
TOTAL FEE PAID (If Different Than Fee Due)				N/A

(X) A check in the amount of \$1,300 to cover the Total Fee Due is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required, now or in the future, or credit any overpayment to Account No. 11-1410.


Neil S. Bartfeld, Ph.D.
Registration No. 39,901
Agent of Record
Customer No. 20,995
(619) 235-8550

Knobbe Martens Olson & Bear LLP

Intellectual Property Law

10/578398

2040 Main Street
Fourteenth Floor
Irvine, CA 92614
Tel 949-760-0404
Fax 949-760-9502
www.kmob.com

AP20 Rec'd PCT/PTO 04 MAY 2006

Neil S. Bartfeld, Ph.D.
Patent Agent
619-525-8312
Neil.Bartfeld@kmob.com

MAIL STOP PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION BY "EXPRESS MAIL"

Attorney Docket No. : SHIGA7.049APC
Applicant(s) : Washio et al.
For : THICK FILM PHOTORESIST
COMPOSITION AND METHOD OF
FORMING RESIST PATTERN
Agent : Neil S. Bartfeld, Ph.D.
"Express Mail" Label No. : EV 465565784 US
Date of Deposit : May 4, 2006

The following documents are hereby placed into an Express Mail envelope bearing the number indicated above, which envelope is being deposited today with the U.S. Postal Service as Express Mail:

Transmittal letter; Preliminary Amendment in 5 pages; a copy of form PCT/IB/304 for the International Application; a copy of the International Search Report for the International Application; a copy of the published International Application; SIGNED Declaration and Power of Attorney (with copy of Assignment) in 4 pages; Recordation Form Cover Sheet and Assignment in 3 pages; Information Disclosure Statement, PTO Form PTO/SB/08 Equivalent with 1 reference enclosed; Check for Filing Fees; Return Prepaid Postcard.

The envelope, with the enclosures listed above, is addressed the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

San Diego
619-235-8550

San Francisco
415-954-4114

Los Angeles
310-551-3450

Riverside
951-781-9231

San Luis Obispo
805-547-5580

10/578398

APR 20 2006 Rec'd PCT/PTO 04 MAY 2006

This submission is being made in compliance with 37 CFR 1.10.

Vanessa C. Langer
Name: Vanessa C. Langer
Docketing Agent

2577110: cey
050406